

## PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1  
 Stylesheet Version v1.2

EPAS ID: PAT4440888

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
CHIEH-HSIUNG KUAN	05/31/2017
CHUN NIEN	05/26/2017
WEN-SHENG SU	05/26/2017
LI-CHENG CHANG	05/31/2017
CHENG-HUAN CHUNG	05/31/2017
WEI-CHENG RAO	05/11/2017
HSIU-YUN YEH	05/24/2017
SHAO-WEN CHANG	05/25/2017
KUAN-YUAN SHEN	05/31/2017
SUSUMU ONO	05/16/2017
<b>RECEIVING PARTY DATA</b>	
<b>Name:</b>	NATIONAL TAIWAN UNIVERSITY
<b>Street Address:</b>	NO.1, SEC. 4, ROOSEVELT ROAD
<b>City:</b>	TAIPEI
<b>State/Country:</b>	TAIWAN
<b>Postal Code:</b>	10617
<b>PROPERTY NUMBERS Total: 1</b>	
<b>Property Type</b>	<b>Number</b>
<b>Application Number:</b>	15610644
<b>CORRESPONDENCE DATA</b>	
<b>Fax Number:</b>	(888)388-6582
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
<b>Phone:</b>	8883886609
<b>Email:</b>	info@ckc-ip.com
<b>Correspondent Name:</b>	CKC & PARTNERS CO., LTD.
<b>Address Line 1:</b>	ROOM 1901, 19/F, LEE GARDEN ONE,
<b>Address Line 2:</b>	33 HYSAN AVENUE, CAUSEWAY BAY
<b>Address Line 4:</b>	HONG KONG, HONG KONG
<b>ATTORNEY DOCKET NUMBER:</b>	TWT05274/US

PATENT

<b>NAME OF SUBMITTER:</b>	JAMES LYNN O'SULLIVAN
<b>SIGNATURE:</b>	/James Lynn O'Sullivan/
<b>DATE SIGNED:</b>	06/02/2017

**Total Attachments: 30**

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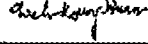
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<u>Chieh-Hsiung KUAN</u>	<u></u>	<u>2017/05/31</u>
Name of sole or first inventor	Signature	Date
<u>Chun NIEN</u>	<u></u>	<u></u>
Name of second inventor, if any	Signature	Date
<u>Wen-Sheng SU</u>	<u></u>	<u></u>
Name of third inventor, if any	Signature	Date
<u>Li-Cheng CHANG</u>	<u></u>	<u></u>
Name of fourth inventor, if any	Signature	Date
<u>Cheng-Huan CHUNG</u>	<u></u>	<u></u>
Name of fifth inventor, if any	Signature	Date
<u>Wei-Cheng RAO</u>	<u></u>	<u></u>
Name of sixth inventor, if any	Signature	Date
<u>Hsiu-Yun YEH</u>	<u></u>	<u></u>
Name of seventh inventor, if any	Signature	Date
<u>Shao-Wen CHANG</u>	<u></u>	<u></u>
Name of eighth inventor, if any	Signature	Date

Kuan-Yuan SHEN

Name of ninth inventor, if any

Signature

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Susumu ONO

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Name of sole or first inventor

Signature

Date

Chun NIEN

Name of second inventor, if any

Signature

Date

Wen-Sheng SU

Name of third inventor, if any

Signature

Date

Li-Cheng CHANG

Name of fourth inventor, if any

Signature

Date

Cheng-Huan CHUNG

Name of fifth inventor, if any

Signature

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\_\_\_\_\_  
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Susumu ONO

Name of tenth inventor, if any

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Wen-Sheng SU

2017.5.26

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Name of fourth inventor, if any

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Name of fifth inventor, if any

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The ASSIGNOR(S) authorize(s) the attorneys and agents who have the power of attorney in this application to check any appropriate boxes and to insert the Serial Number and filing date in this document after it has been executed.

Chieh-Hsiung KUAN

Name of sole or first inventor

Signature

Date

Chun NIEN

Name of second inventor, if any

Signature

Date

Wen-Sheng SU

Name of third inventor, if any

Signature

Date

Li-Cheng CHANG

Name of fourth inventor, if any

Signature

Date

Cheng-Huan CHUNG

Name of fifth inventor, if any

Signature

Date

Wei-Cheng RAO

Name of sixth inventor, if any

Wei-Cheng Rao  
Signature

2017/5/19  
Date

Hsiu-Yun YEH

Name of seventh inventor, if any

Signature

Date

Shao-Wen CHANG

Name of eighth inventor, if any

Signature

Date

Kuan-Yuan SHEN

Name of ninth inventor, if any

Signature

Date

Susumu ONO

Name of tenth inventor, if any

Signature

Date

**ASSIGNMENT**

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Electron-Beam Lithography Method and System

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☐ (other) \_\_\_\_\_

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Name of sole or first inventor	Signature	Date
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Name of fifth inventor, if any	Signature	Date
<u>Wei-Cheng RAO</u>	_____	_____
Name of sixth inventor, if any	Signature	Date
<u>Hsiu-Yun YEH</u>		<u>2017/05/24</u>
Name of seventh inventor, if any	Signature	Date
<u>Shao-Wen CHANG</u>	_____	_____
Name of eighth inventor, if any	Signature	Date

Kuan-Yuan SHEN

Name of ninth inventor, if any

Signature

Date

Susumu ONO

Name of tenth inventor, if any

Signature

Date

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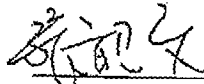
Date

Shao-Wen CHANG

Name of eighth inventor, if any

Signature

Date



05/25/2017

Kuan-Yuan SHEN

Name of ninth inventor, if any

Signature

Date

Susumu ONO

Name of tenth inventor, if any

Signature

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Signature

Date

Kuan-Yuan SHEN

Name of ninth inventor, if any

Kuan Yuan Shen

Signature

2017/05/31

Date

Susumu ONO

Name of tenth inventor, if any

Signature

Date

PATENT

REEL: 042669 FRAME: 0228

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Susumu Ono  
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Date